



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

September 1, 2026	
IGI Report Number	LG834610012
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	PRINCESS CUT
Measurements	5.89 X 5.79 X 3.98 MM

GRADING RESULTS

Carat Weight	1.19 CARAT
Color Grade	E
Clarity Grade	VS 1

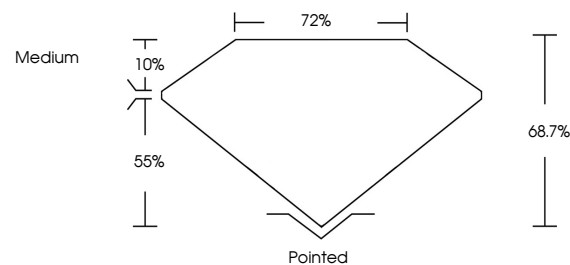
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG834610012

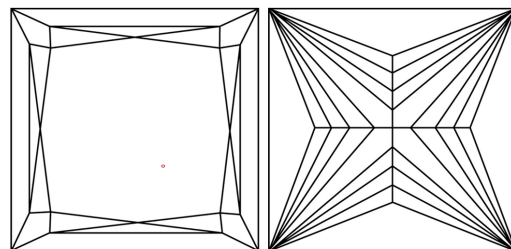
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG834610012
Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

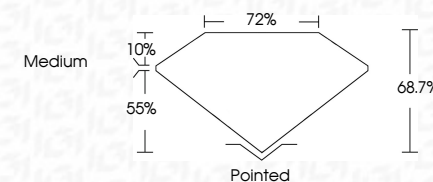
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September 1, 2026
IGI Report No LG834610012

Report No. 16834610012 PRECINSS CUT 6.95 X 5.79 X 3.98 MM	Carat Weight Color Grade	VS 1 68.7% 72% Medium	Polished EXCELLENT EXCELLENT NONE None (GIA/4010012)
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